

<b>Notice of References Cited</b>	Application/Control No. 10/764,774	Applicant(s)/Patent Under Reexamination DE VROOME, CLEMENS JOHAN	
	Examiner Laura Edwards	Art Unit 1734	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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**FOREIGN PATENT DOCUMENTS**

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	N	WO02/093269	11-2002	WO	Ichida et al	
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**NON-PATENT DOCUMENTS**

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